

U.S. Application No. 10/752,642
 Reply to Office Action mailed November 2, 2006

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PATENT
 790001-2042

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Naofumi Nakamura et al.
 Serial No. : 10/752,642
 For : SEMICONDUCTOR DEVICE AND METHOD OF
 FABRICATING THE SAME
 Filing Date : January 7, 2004
 Examiner : Jesse A. Fenty
 Group Art Unit : 2815
 Confirmation No. : 4109

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RESPONSE

MAIL STOP AMENDMENT
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

This response is submitted in reply to the Final Office Action in the above-captioned
 application mailed on November 2, 2006, having a three-month statutory period for response set
 to expire on February 2, 2007. Applicants respond as follows.